

10/549900
JC17 Rec'd PCT/PTO 20 SEP 2005

03500.017975.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
SHUNICHI ISHIHARA) Examiner: Not Yet Assigned
Application No.: Not Yet Assigned)
Nati'l. Pharse of PCT/JP2004/004072) Art Unit: Not Yet Assigned
filed March 24, 2004)
Filed: Concurrently Herewith)
For: SOLAR CELL : September 19, 2005

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed foreign documents are also enclosed.

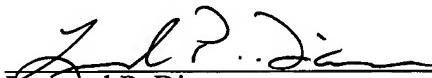
It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

10/549900

JC17 Rec'd PCT/PTO 20 SEP 2005

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,


Leonard P. Diana
Attorney for Applicant
Registration No. 29,296

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3800
Facsimile: (212) 218-2200

FORM PTO 1449 (modified)			ATTY DOCKET NO. 03500.017975		APPLICATION NO. National. Phase of PCT/JP2004/004072 filed 3/24/04 10/54990		
U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			APPLICANT SHUNICHI ISHIHARA				
LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)			FILING DATE Concurrently Herewith		GROUP N.Y.A.		
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		5,403,771	04/04/95	Nishida et al.	437	89	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
JP		3-228324	10/09/91	Japan	H01L	21/208	Abstract
JP		2001-217442A	08/10/01	Japan	H01L	31/04	Abstract
JP		2001-332494A	11/30/01	Japan	H01L	21/20	Abstract
JP		9-312258	12/02/97	Japan	H01L	21/20	Abstract
JP		04-225282	08/14/92	Japan	H01L	31/04	Abstract
JP		10-107302	04/24/98	Japan	H01L	31/04	Abstract
JP		2001-237446A	08/31/01	Japan	H01L	31/04	Abstract
JP		5-36611	02/12/05	Japan	H01L	21/205	Abstract
W0		92/12542	07/23/92	EPO	H01L	31/18	Abstract
DE		41 93 392 T1	12/10/92	Germany	H01L	31/0392	Abstract
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
		"Investigation of Polycrystalline Silicon Deposition on Glass Substrates", Zhengrong Shi et al., Solar Energy Materials and Solar Cells 31 (1993) 51-60, Holland, pgs. 51-60					
EXAMINER				DATE CONSIDERED			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Sheet 1 of 1